



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Christopher M. Look

Application No.: 10/785,618

Filed: February 23, 2004

Attorney Docket No.: 6518P009

For: A METHOD AND AN APPARATUS TO  
PROVIDE OPTICAL EQUIPMENT  
PROTECTION

Examiner: Wai Lun Leung

Art Unit: 2613

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114

Sir:

In response to the final Office Action mailed October 3, 2007, Applicant respectfully submits a Request for Continued Examination under 37 C.F.R. § 1.114. Please enter the following amendments and consider the remark below:

**FIRST-CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Mail Stop AF, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

Date of Deposit

Joyce Klein

Name of Person Mailing Correspondence

Signature

Date